



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

		•	: Onit: 2891 : Caridad Everhai
In Re PATE	NT APPLICATION of:	Examinor	. Gundad Evernal
Applicant(s):	Mineo MIURA	)	
Serial No.:	10/585,108	)	
Filing Daté:	June 30, 2006	. )	) ) ) <b>AMENDMENT</b>
For:	PRODUCTION METHOD FOR SEMICONDUCTOR DEVICE	) ) )	AMENDIMENT
Docket No.:	AI 418NP	)	

July 21, 2008

**Mail Stop Amendment**Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on April 22, 2008, please amend the above-identified application as follows: